

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Takashi OGAWA :
Appln. No. [not yet assigned] :
Filed: August 18, 2006 :
For: SEMICONDUCTOR INSPECTION :
METHOD AND SYSTEM :
THEREFOR : Docket No. S005-5850(PCT)

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S I R:

Applicant preliminarily amends his application
before calculation of the filing fee as follows:

BY EXPRESS MAIL ON AUGUST 18, 2006 (EV 666 011 623 US)